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PATENT

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Application of: Zheng Lu, et al. Art Unit: 1722
Serial No.: 10/699,038
Filed: October 31, 2003
Confirmation No.: 1197
For: PROCESS FOR PREPARING SINGLE CRYSTAL SILICON USING CRUCIBLE
ROTATION TO CONTROL TEMPERATURE GRADIENT
Examiner: Robert M. Kunemund

November 14, 2005

RESPONSE TO OFFICE ACTION

TO THE COMMISSIONER FOR PATENTS,

SIR:

In response to the Office action mailed June 14, 2005, please enter the following amendments and consider the following remarks.

Remarks begin on page 2 of this paper.

Conclusion begins on page 11 of this paper.